

**Appl. No.** : 10/618,900  
**Filed** : July 14, 2003

### **SUMMARY OF INTERVIEW**

Applicant wishes to thank Examiner Rudy Zervigon for the courteous telephone interview extended to their representative that was conducted on July 14, 2006.

#### **Exhibits or demonstrations shown**

None.

#### **Identification of Prior Art Discussed**

Kajita (US 5,653,634) and Hayakawa (US 5,447,568) were discussed.

#### **Proposed Amendments**

Applicant's representative suggested inserting the word "exclusively" in the sentence "said vaporization surface having pores distributed in the vicinity of its periphery."

#### **Principal Arguments and Other Matters**

Hayakawa's plate is a gas ratifying plate, not an evaporation plate.

Kajita's plate is an evaporation plate but is not disposed between the ceiling of the chamber and the shower plate. Further, Kajita's plate has no pore.

Hayakawa's gas ratifying plate could not be replaced with Kajita's evaporation plate because of their different functionality.

Even if the teachings of Hayakawa and Kajita are combined, the combination still could not lead to the claimed invention.

#### **Results of Interview**

The Examiner disagreed with the representative's arguments because Hayakawa's plate could function as an evaporation plate when a gas condenses on its surface even if Hayakawa is silent about the possibility, and Hayakawa and Kajita could at least conceptually (if not structurally) be combined.

The Examiner agreed that the word "exclusively" could distinguish the claimed structures from the prior art.